Se	Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/621,638	YUASA ET AL.
Examiner	Art Unit
Anh D. Mai	2814

SEARCHED				
Class	Subclass	Date	Examiner	
257	758-760	3/28/2005	A.M	
438	618 622-623 787-790	3/29/05	A.M	
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INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
257	758-760	3/29/05	A.M	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST (all): * Inventors * CCLS * dimethyldimethoxysilane and silicon and carbon and dielectric * dimethyldimethoxysilane and silicon and carbon and (flow rate)	3/28/05	A.M
JPO (web): F/Fi term: H01L 23/52 5F068	3/29/05	A.M
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